

ABSTRACT

METHOD OF DEPOSITING MATERIAL

A method for depositing material at an intersection region (116) of at least two surfaces (102,104,106,108,110) of a component (100). The method comprises a first deposition process providing material at said intersection and directing an energy beam (114) toward the intersection region to join the material to the component. The beam is maintained at an obtuse angle relative to at least two of the surfaces such that substantially all of the working area of the beam is incident upon the intersection region.

FIGURE 2